



ISC Audits & Reviews SC Summary (Jan 21st, 2026)

Doc.	Title	Vote
6983A;	Revision to SEMI M49-0918 With Title Change To: Guide for Specifying Geometry Measurement Systems for Silicon Wafers for the 130 nm To 3 nm Technology Generations;	Passed
7194;	New Standard: Specification for 300 mm Film Frame FOUP (FFF) Load Port;	Passed
7349A;	Revision to SEMI S13-0113 (Reapproved 0819), Environmental, Health And Safety Guideline For Documents Provided To The Equipment User For Use With Manufacturing Equipment with the Title change to Environmental, Health, And Safety Guideline For Documents Provided To The Equipment User For Use With Semiconductor Manufacturing Equipment ;	Passed
7373A-LI1;	The following Subordinate Standards are not proposed for revision but will continue to be compatible with the revised Primary Standard: SEMI E182.1 — Specification for Panel FOUP Loadport for 510 to 515 mm Panel Size SEMI E182.2 — Specification for Panel FOUP Loadport for 600 to 600 mm Panel Size;	Passed
7392-LI1;	To update JSNM information;	Passed
7402-LI1;	Clarification of the requirements specification chapter;	Passed
7402-LI2;	Correction of figure title error;	Passed
7402-LI3;	Corrected duplicate numbers and corrected explanations;	Passed
R6743C;	Ratification Ballot, Revision to SEMI E95-1101, Specification for Human Interface for Semiconductor Manufacturing Equipment;	Passed
SEMI T27-1125	Specification for Traceability Identification Label of Component Parts (Type 2 Editorial Changes)	Passed

For more information, please contact the SEMI Standards Engineer/Coordinator.
<http://www.semi.org/standards/contacts>) nearest you.

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